PATENT APPLICATION

| 03500.013395.2 | | | PATENT APPL | |
|--|-----------------------------|--------------------------|-------------|-----------------------|
| O T R | 2 1 2005 | IN THE UNITED STATES PAT | ENT A | AND TRADEMARK OFFICE |
| Application of: | | |) | |
| KEISHI SAITO, ET AL. | | | : | Examiner: R. Kunemund |
| | | |) | |
| | | | : | Group Art Unit: 1722 |
| | Application No.: 10/625,672 | | | - |
| | Filed: July 24, 2003 | | : | |
| | | |) | |
| | | | : | |
| | For: | SEMICONDUCTOR ELEMENT |) | |
| | | AND ITS MANUFACTURING | : | |
| | | METHOD |) | June 20, 2005 |
| | Mail Stop Amendment | | | |
| Commissioner for Patents P.O. Box 1450 | | | | |
| | | | | |

Alexandria, VA 22313-1450

AMENDMENT AND SUBMISSION OF SWORN TRANSLATIONS

Sir:

In response to the Office Action dated March 24, 2005, please amend the above-identified application, as follows: